



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## \*BIBDATASHEET\*

CONFIRMATION NO. 6935

Bib Data Sheet

SERIAL NUMBER 10/759,093	FILING DATE 01/20/2004  RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. SEC.889D
-----------------------------	---------------------------------------	--------------	------------------------	------------------------------------

APPLICANTS

Moon-hee Lee, Suwon-city, KOREA, REPUBLIC OF;  
 Kun-tack Lee, Suwon-city, KOREA, REPUBLIC OF;  
 Woo-gwan Shim, Seoul, KOREA, REPUBLIC OF; Jong-ho Chung, Seoul, KOREA, REPUBLIC OF;

\*\* CONTINUING DATA ..... *MK (Verified)*  
 This application is a DIV of 10/012,564 12/12/2001 PAT 6,701,942

\*\* FOREIGN APPLICATIONS ..... *MK (Verified)*  
 REPUBLIC OF KOREA 2001-16327 03/28/2001

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 04/21/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance <i>ufo</i> Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 4	TOTAL CLAIMS 8	INDEPENDENT CLAIMS 1
--	--	---	------------------------	----------------------	----------------------------

ADDRESS  
 20987  
 VOLENTINE FRANCO, & WHITT PLLC  
 ONE FREEDOM SQUARE  
 11951 FREEDOM DRIVE SUITE 1260  
 RESTON, VA  
 20190

TITLE  
 Method of and apparatus for removing contaminants from surface of a substrate

<input type="checkbox"/> All Fees
-----------------------------------